

TITLE OF THE INVENTION

AMPLIFICATION TYPE SOLID-STATE IMAGING DEVICE HAVING A  
POTENTIAL DETECTING CIRCUIT FOR EACH UNIT CELL AND  
HIGH-SPEED READOUT METHOD THEREOF

5 CROSS-REFERENCE TO RELATED APPLICATIONS

This application is based upon and claims the  
benefit of priority from the prior Japanese Patent  
Application No. 2000-090061, filed March 29, 2000, the  
entire contents of which are incorporated herein by  
10 reference.

BACKGROUND OF THE INVENTION

This invention relates to a so-called  
amplification type solid-state imaging device having a  
potential detecting circuit for each unit cell and a  
15 high-speed readout method thereof and more particularly  
to a solid-state imaging device which is operated at  
high speed while suppressing a lowering in the signal-  
noise ratio (S/N ratio).

Recently, solid-state imaging devices which are  
20 called amplification type solid-state imaging devices  
each having a potential detecting circuit for each unit  
cell are actively developed. In comparison with a CCD  
type solid-state imaging device conventionally used,  
since the charge transfer operation is effected only in  
25 an area around the photodiodes in this type of solid-  
state imaging device, the power and voltage required  
for the charge transfer operation become unnecessary

and it is advantageously used for mobile applications in which it is driven by a battery or the like. In this case, however, there occurs a problem that the S/N ratio is lowered by a variation in the characteristic of the potential detecting circuit provided for each unit cell and studies on this matter are actively continued.

FIG. 1 shows the schematic construction of the amplification type solid-state imaging device. In FIG. 1, an example of the solid-state imaging device having two photodiodes arranged in each unit cell is shown.

In an imaging area on a semiconductor substrate, unit cells are arranged in a two-dimensional fashion. More precisely, the unit cells are arranged in  $i$  rows and  $j$  columns, where  $i$  and  $j$  are integers. Of these unit cells, six representative ones are illustrated in FIG. 1. The six unit cells  $P$  are arranged in two adjacent rows  $m$  and  $m+1$  and three adjacent columns  $n-1$ ,  $n$  and  $n+1$ ; they are located at intersections  $(m, n-1)$ ,  $(m, n)$ ,  $(m, n+1)$ ,  $(m+1, n-1)$ ,  $(m+1, n)$  and  $(m+1, n+1)$ .

An address pulse line  $LAD_i$ , first and second readout pulse lines  $LR1_i$ ,  $LR2_i$  and reset pulse line  $LRS_i$  are arranged in the horizontal direction for each pixel row of the unit cells  $P(i, j)$ . The unit cells  $P(i, j)$  are supplied with an address pulse  $\phi AD_i$ , first and second readout pulses  $\phi R1_i$ ,  $\phi R2_i$ , and reset pulse

$\phi RSi$  from a pulse generating section 20 via the address pulse line  $LADi$ , first and second readout pulse lines  $LR1i$ ,  $LR2i$  and reset pulse line  $LRSi$ .

Further, a vertical signal line  $Sj$  is provided in  
5 the vertical direction for each column of the unit cells  $P(i,j)$ . A current source  $Ij$  is provided between one end of each of the vertical signal lines  $Sj$  and the ground node. The other end of each vertical signal  
10 line  $Sj$  is connected to one end of the current path of a shift transistor (shift gate)  $SHj$ . The gates of the shift transistors  $SHj$  are commonly connected to a shift pulse line  $LSH$ .

One electrode of each coupling capacitor  
(capacitance)  $CAj$  is connected to the other end of the  
15 current path of the shift transistor  $SHj$  and the current path of a horizontal readout transistor (horizontal readout gate)  $Hj$  is connected between the other electrode of a corresponding one of the  
20 capacitors  $CAj$  and a horizontal signal line 24. The gate of the horizontal readout transistor  $Hj$  is connected to a corresponding one of horizontal readout pulse lines  $LHj$ . A capacitor which is equivalently represented by a capacitor 25 is associated with the horizontal signal line 24.

25 Charge storage capacitors (capacitances)  $CBj$  are respectively connected between the other electrodes of the capacitors  $CAj$  and the ground node. The current

paths of clamping transistors (clamping gates) CLPj for offset elimination are respectively connected between connection nodes of the capacitors CAj and CBj and the positive terminal of a clamping DC power supply 23.

5 The gates of the transistors CLPj are connected to a clamp line LCLP.

The shift transistor SHj, capacitors CAj, CBj and clamping transistor CLPj constitute a noise canceller circuit.

10 A pulse generating section 21 supplies a shift pulse  $\phi_{SH}$  to the gates of the shift transistors SHj via the shift pulse line LSH and supplies a clamp pulse  $\phi_{CLP}$  to the gates of the clamping transistors CLPj via the clamp pulse line LCLP to control the operations  
15 thereof.

Further, a pulse generating section 22 respectively supplies horizontal readout pulses  $\phi_{Hj}$  to the gates of the horizontal readout transistors Hj via the horizontal readout pulse lines LHj and supplies a  
20 clear pulse  $\phi_{CR}$  to the gate of a potential resetting transistor (potential resetting gate) 28 via a clear pulse line LCR. The potential resetting transistor 28 is used for resetting the potential of the capacitor (capacitance) 25, and one end of the current path  
25 thereof is connected to the positive terminal of a DC power supply 29 for generating a potential at the reset time and the other end of the current path thereof is

connected to the horizontal signal line 24. The voltage value (which is indicated by  $V_b$ ) of the DC power supply 29 is determined by taking the characteristic of an output buffer circuit 26 into consideration and the clear pulse  $\phi_{CR}$  is supplied to the gate of the transistor 28 to set the potential of the capacitor 25 to the potential  $V_b$  before the horizontal readout pulses  $\phi_{Hj}$  are supplied.

The horizontal signal line 24 is connected to the input terminal of the output buffer circuit 26 for detecting the potential of the horizontal signal line 24, subjecting the potential to impedance conversion and outputting the potential to the exterior. The output end of the output buffer circuit 26 is connected to an output terminal 27.

Next, the internal construction of the unit cell  $P(i,j)$  is explained. In FIG. 1, the unit cell  $P(m, n-1)$  is taken as an example and shown in detail, but the other unit cells are also constructed in the same manner. Each unit cell  $P(i,j)$  includes photodiodes 1-1, 1-2, readout transistors (readout gates) 2-1, 2-2, reset transistor (reset gate) 4, potential detecting transistor (potential detecting gate) 5, address transistor (address gate) 6 and the like.

The anodes of the photodiodes 1-1, 1-2 are grounded and the cathodes thereof are respectively

connected to one-side ends of the current paths of the readout transistors 2-1, 2-2. The other ends of the current paths of the readout transistors 2-1, 2-2 are connected to a storage node 3 (common charge detecting section) in which charges read out from the photodiodes 1-1, 1-2 are temporarily stored and the gates thereof are respectively connected to the readout pulse lines LR1i, LR2i. The reset transistor 4 is connected between the storage node 3 and a power supply 7 and the gate of the reset transistor 4 is connected to a corresponding one of the reset pulse lines LRSi. One end of the current path of the potential detecting transistor 5 is connected to a corresponding one of the vertical signal lines Sj via the output line 8 of the corresponding unit cell P(i,j) and the gate thereof is connected to the storage node 3. The potential detecting transistor 5 is used for detecting the charges transferred to the storage node 3 and transmits a potential corresponding to an amount of detected charges to the vertical signal line Sj via the output line 8. The current path of the address transistor 6 is connected between the other end of the current path of the potential detecting transistor 5 and the power supply 7 and the gate thereof is connected to the address pulse line LADi. The address transistor 6 is used for activating the potential readout operation for the corresponding unit cell P(i,j). In FIG. 1, in

order to clarify the drawing, power supply lines are omitted.

With the above construction, part of the circuit elements of the unit cell can be commonly used for the photodiodes 1-1, 1-2 and the integration density can be enhanced. However, since the symmetry of the circuit arrangement and pattern arrangement of the surrounding portions of the photodiodes 1-1, 1-2 cannot be maintained, the tolerance for the mask alignment in the manufacturing process becomes severe. That is, the manufacturing technique and the integration density are set in the trade-off relation.

Next, the operation of the amplification type solid-state imaging device shown in FIG. 1 is explained with reference to the timing charts shown in FIGS. 2 and 3. FIG. 2 shows pulse timings for driving the amplification type solid-state imaging device and FIG. 3 shows the relation between the horizontal readout pulses  $\phi H1$ ,  $\phi H2$ ,  $\phi H3$ , ... and the clear pulse  $\phi CR$ .

In FIGS. 2 and 3, a standard television system is assumed. In FIG. 2, HBLK indicates a horizontal sync. pulse and the high-level period is a horizontal scanning retrace interval. The low-level period of the horizontal sync. pulse HBLK is a horizontal effective scanning period and a horizontal readout pulse  $\phi Hj$  is

generated during this period. The horizontal scanning retrace interval and the horizontal effective scanning period constitute one horizontal scanning period (1H). In the horizontal scanning period, each signal readout operation from each of the unit cells is effected during the horizontal scanning retrace interval and the readout signal is stored in the capacitor CBj in the form of charges. After this, the horizontal readout transistors Hj are sequentially turned ON in the horizontal effective scanning period to connect the capacitor 25 in parallel with the capacitors CAj, CBj, thereby reading out the stored signal charges. The signal readout operation in this period is commonly effected for the unit cells arranged in the horizontal direction.

Next, the above readout operation is explained in more detail by taking the photodiodes 1-1 of the unit cell P(m, n-1) as an example. Charges created by photoelectrically converting light incident on the photodiode 1-1 are stored in the photodiode 1-1 until the readout transistor 2-1 is turned ON. The operation which is first effected in the horizontal scanning retrace interval is to set the address pulse  $\phi_{ADm}$  to the high level so as to turn ON the address transistor 6 ( $t=t_0$ ) and construct a source-follower circuit by use of the vertical signal line Sn-1, current source In-1 and potential detecting transistor 5 so that the charge



of the storage node 3 can be detected by use of the potential detecting transistor 5. As a result, only a potential corresponding to the charge amount of the storage node 3 and determined by the gate potential of the potential detecting transistor 5 is transmitted to the vertical signal line Sn-1.

Further, a dark current integrated value stored in the storage node 3 can be discharged by setting the reset pulse  $\phi RSm$  to the high level to turn ON the reset transistor 4 at the beginning of the horizontal scanning retrace interval. Thus, the storage node 3 can be set at the power supply voltage value (which is denoted by Vdd).

It is now assumed that the capacitance of the storage node 3 is  $C_{ij}$  when the charge  $Q$  is transferred from the photodiode 1-1 to the storage node 3. Then, the potential  $V_3$  of the storage node 3 can be expressed by the following equation (1).

$$V_3 = V_{dd} + Q/C_{ij} \quad \dots (1)$$

where  $V_{dd}$  is a power supply voltage.

When the above value is detected by the potential detecting transistor 5, the potential  $V_8$  of the output line 8 takes a value expressed by the following equation (2).

$$\begin{aligned} V_8 &= mV_3 + V_0 \\ &= m(V_{dd} + Q/C_{ij}) + V_0 \\ &= mQ/C_{ij} + mV_{dd} + V_0 \quad \dots (2) \end{aligned}$$

where  $m$  is the modulation degree of the transistor and  $V_0$  is an offset voltage determined by variations in the current source  $I_{n-1}$  and the threshold voltage of the potential detecting transistor 5.

5           In the present manufacturing technology, the modulation degree  $m$  can be suppressed to a small variation for the entire surface of the wafer, but the offset voltage  $V_0$  cannot be always suppressed to a small variation and is considered as an amount which  
10           varies depending on the vertical signal lines. Therefore, the modulation degree  $m$  can be regarded as being constant, but it is necessary to correct the offset voltage  $V_0$ . The correction is made in the next operation.

15           The potential  $V_8$  of the output line 8 and the potential  $V_A$  of a node  $NA$  which is a connection node of the capacitors  $CA_j$  and  $CB_j$  in the noise canceller circuit are considered while it is assumed that the potential of the DC power supply 23 is  $V_{ref}$ . It is  
20           supposed that  $V_8$  is expressed by the following equation (3) at the time  $t=t_1$  immediately after the resetting operation.

$$V_8 = mV_{dd} + V_0 = V_1 \quad \dots (3)$$

25           After this, at the time  $t=t_2$  immediately after application of the clamp pulse  $\phi_{CLP}$ , the potential  $V_8$  of the output line 8 is kept at  $V_1$ , but  $V_A$  is set to a value expressed as follows.

$$V_A = V_{ref} \quad \dots (4)$$

That is, a potential difference ( $V_{ref}-V_1$ ) appears across the capacitor  $C_{An-1}$ . The potential of the electrode of the capacitor  $C_{Bn-1}$  opposite to the electrode thereof which is grounded is set to a potential of  $V_{ref}$ . Next, the readout pulse  $\phi_{R1n}$  is set to the high level to turn ON the readout transistor 2-1 so that the charge  $Q$  stored in the photodiode 1-1 can be transferred to the storage node 3. As a result, at the time  $t=t_3$ ,  $V_8$  is set to the following value.

$$V_8 = mQ/C_{ij}+V_1 \quad \dots (5)$$

Therefore, the potential  $V_A$  of the node  $NA$  is set to a voltage expressed by the following equation (6).

$$V_A = V_{ref}+mQ/C_{ij} \cdot C_{Aj}/(C_{Aj}+C_{Bj}) \quad \dots (6)$$

After this, the shift pulse  $\phi_{SH}$  is set to the low level to turn OFF the shift transistor  $SH_{n-1}$  and separate the vertical signal line  $S_{n-1}$ . If charges stored in the capacitor 25 and capacitor  $C_{Bj}$  in this state ( $t=t_4$ ) are respectively indicated by  $Q_1$ ,  $Q_2$  and when the capacitance of the capacitor 25 is  $CH$  and the voltage value of the DC power supply 29 is  $V_b$ , then the charges  $Q_1$ ,  $Q_2$  are expressed by the following equations (7) and (8).

$$Q_1 = CH \cdot V_b \quad \dots (7)$$

$$Q_2 = C_{Bj}V_{ref}+mQ/C_{ij} \cdot C_{Aj}C_{Bj}/(C_{Aj}+C_{Bj}) \quad \dots (8)$$

If the horizontal readout pulse  $\phi_{Hn-1}$  is set to the high level to turn ON the horizontal readout

transistor  $H_{n-1}$ , the capacitors are connected in parallel and the potential of the horizontal signal line 24 is set to a value expressed by the following equation (9).

$$\begin{aligned} & (Q_1+Q_2)/(C_H+C_{Bj}) \\ & = (C_H \cdot V_b + C_{Bj} V_{ref}) / (C_H + C_{Bj}) + mQ / C_{ij} \cdot C_{Aj} C_{Bj} / (C_{Aj} + C_{Bj}) \\ & \dots (9) \end{aligned}$$

After this, as shown in the timing chart of FIG. 3, the clear pulse  $\phi_{CR}$  is set to the high level in the low-level period of the horizontal sync. pulse HBLK and then a corresponding one of the horizontal readout pulses  $\phi_{H1}$ ,  $\phi_{H2}$ ,  $\phi_{H3}$ , ... is sequentially set to the high level so as to change the potential of the horizontal signal line 24 and thus perform the readout operation.

As is clearly understood from the equation (9), the potential of the horizontal signal line 24 contains a single constituent factor except that it contains the capacitances  $C_{Aj}$ ,  $C_{Bj}$  as an amount which may vary for each line and  $C_{ij}$  which may vary for each unit cell. That is, it does not contain  $V_0$  shown in the equation (3) and varying according to the threshold voltage or the like and is effectively corrected based on the value of the potential  $V_8$  of the output line 8.

Further, it is understood by specifically studying the equation (9) that the potential is determined not by the absolute values of the capacitances but by the

ratios thereof except the item of  $mQ/C_{ij}$ . This means that the output voltage is determined not by the absolute value of the film thickness of the gate oxide film, for example, but by the ratio of the geometrical sizes of the patterns of the capacitors and a reduction in the variation can be relatively easily attained by the present manufacturing technology. Since the modulation degree  $m$  of the transistor is a relatively easily controllable variable, can be attained with a less variation as described before and can be regarded as being substantially constant, the potential is slightly influenced only by  $C_{ij}$  acting as an amount which may vary for each unit cell.

Basically, it is considered to reduce the number of photodiodes used for charge readout in order to drive the solid-state imaging device with the construction as shown in FIG. 1 at high speed.

The operation timings used for attaining the high-speed operation are shown in FIGS. 4 and 5. FIG. 4 shows the operation timing used when only one of the two photodiodes in each unit cell is used for the readout operation. In the operation timing shown in FIG. 4, signal charges are read out only from the photodiode 1-1 and charges stored in the photodiode 1-2 are discharged via the storage node 3 by supplying the readout pulse  $\phi R2m$  in synchronism with the reset pulse  $\phi RSm$  to simultaneously turn ON the reset transistor 4

and readout transistor 2-2. As a result, the readout speed for one frame is enhanced to twice the normal readout speed.

FIG. 5 is a timing chart wherein the same idea is applied to a pixel column, the readout operation is effected only for the even columns without effecting the readout operation for the odd columns. That is, the horizontal readout pulses  $\phi H1$ ,  $\phi H3$ ,  $\phi H5$ , ... for the odd columns are fixed at the low level and the horizontal readout pulses  $\phi H2$ ,  $\phi H4$ ,  $\phi H6$ , ... for the even columns are sequentially set to the high level to perform the readout operation. As a result, the readout speed for one frame can be enhanced to twice the normal readout speed.

However, the improvement of the operation speed by the above methods is accompanied by a lowering in the S/N ratio. That is, the S/N ratio may be easily lowered since the number of photodiodes used for the readout operation is reduced to half the number of photodiodes used in the normal driving operation.

#### BRIEF SUMMARY OF THE INVENTION

Accordingly, an object of this invention is to provide a solid-state imaging device and a high-speed readout method thereof capable of suppressing a lowering in the S/N ratio even if the high-speed driving operation is effected.

The above object of this invention can be attained

by a solid-state imaging device comprising an imaging area having unit cells arranged in a two-dimensional fashion on a semiconductor substrate, each of the unit cells including first and second photoelectric conversion/storage sections for photoelectrically converting incident light and storing charges thus generated, first and second charge readout circuits for transferring charges stored in the first and second photoelectric conversion/storage sections to a common charge detecting section, a potential detecting circuit for detecting charges transferred to the charge detecting section, generating a potential corresponding to an amount of charges and transmitting the potential to a corresponding one of vertical signal lines, a reset circuit for discharging the charge transferred to the charge detecting section, and an address circuit for selectively activating the potential detecting circuit; a vertical driving circuit provided in correspondence to each pixel row of the imaging area, for driving the first and second charge readout circuits, reset circuit and address circuit of each of the unit cells at preset timings; signal processing circuits respectively attached to the vertical signal lines which are respectively provided for columns of the unit cells, for performing required signal processes; a horizontal driving circuit for scanning outputs of the signal processing circuits in a

horizontal direction at preset timings to detect the same; and an output circuit for outputting output signals of the signal processing circuits detected by the scanning operation by the horizontal driving circuit; wherein the solid-state imaging device has a first operation mode in which the first and second charge readout circuits are driven at substantially the same timing by the vertical driving circuit, the charges stored in the first and second photoelectric conversion/storage sections are transferred to and added together in the charge detecting section, and the potential detecting circuit detects the added charges, generates and transmits a potential corresponding to the amount of the detected charges to the vertical signal line, and outputs the potential from the output circuit via the signal processing circuits.

With the above construction, since the charges read out from the first and second photoelectric conversion/storage sections in each of the unit cells are transferred to and added together in the common charge detecting section and the added charges are detected and read out by the potential detecting circuit, a sufficient amount of readout charges can be attained and a lowering in the S/N ratio can be suppressed when the high-speed driving operation is effected.

Further, the object of this invention can be



attained by a solid-state imaging device comprising an imaging area having unit cells arranged in a two-dimensional fashion on a semiconductor substrate, each of the unit cells including a photoelectric

5 conversion/storage section for photoelectrically converting incident light and storing charges thus generated, a charge readout circuit for transferring charges stored in the photoelectric conversion/storage section to a charge detecting section, a potential

10 detecting circuit for detecting charges transferred to the charge detecting section, generating a potential corresponding to an amount of detected charges and transmitting the potential to a corresponding one of vertical signal lines, a reset circuit for discharging

15 the charges transferred to the charge detecting section, and an address circuit for selectively activating the potential detecting circuit; a vertical driving circuit provided in correspondence to each pixel row of the imaging area, for driving the charge readout circuit, reset circuit and address circuit of each of the unit

20 cells at preset timings; signal processing circuits respectively attached to the vertical signal lines which are respectively provided for columns of the unit cells, for performing required signal processes;

25 horizontal readout switching circuits for controlling transfer of outputs of the signal processing circuits corresponding to the respective vertical signal lines

to a horizontal signal line, a horizontal driving  
circuit for controlling the horizontal readout  
switching circuits at preset timing; and an output  
circuit for outputting output signals of the signal  
5 processing circuits which are read out to the  
horizontal signal line by controlling the horizontal  
readout switching circuits by use of the horizontal  
driving circuit; wherein the solid-state imaging device  
has a first operation mode in which the horizontal  
10 driving circuit sequentially turns ON the horizontal  
readout switching circuits corresponding to the  
vertical signal lines to sequentially output the output  
signals of the signal processing circuits corresponding  
to the vertical signal lines from the output circuit  
15 via the horizontal signal line and a second operation  
mode in which the horizontal driving circuit turns ON  
the horizontal readout switching circuits corresponding  
to a plurality of vertical signal lines at substan-  
tially the same time to read out the output signals of  
20 the signal processing circuits corresponding to the  
plurality of vertical signal lines to the horizontal  
signal line, average the output signals, and output the  
output signals from the output circuit.

With the above construction, since the signals  
25 derived from the respective vertical signal lines are  
sequentially read out in the first operation mode and  
the signals derived from plural columns of the vertical

signals lines are averaged and read out in the second operation mode, a certain amount of readout charges can be attained in the second operation mode in which the high-speed driving operation is effected and the S/N ratio can be improved over a case wherein the number of readout photodiodes is reduced. Further, since the common horizontal readout switching circuits are used in the first and second operation modes, occurrence of fixed pattern noise can be sufficiently avoided in comparison with a case wherein different transistors are used depending on the modes when the horizontal readout switching circuits are constructed by transistors.

Further, with the above construction, plural columns of vertical signal lines used for averaging the signals simply by changing the timings can be selected and the output signals of the signal processing circuits attached to the respective vertical signal lines can be directly read out to the horizontal signal line without using the capacitive coupling. Therefore, particularly, when signals read out from the vertical signal lines which are not adjacent to each other are averaged, it is unnecessary to capacitively couple the plural columns to the horizontal signal line over a signal line. Thus, a problem of signal crosstalk which tends to occur when the plural columns are capacitively coupled over the signal line can be avoided and it is

particularly preferable when signals are averaged by use of a color sensor using an RGB stripe filter.

The above object of this invention can be attained by a readout method of a solid-state imaging device which includes an imaging area having unit cells arranged in a two-dimensional fashion on a semiconductor substrate, each of the unit cells including first and second photoelectric conversion/storage sections for photoelectrically converting incident light and storing charges thus generated, first and second charge readout circuits for transferring charges stored in the first and second photoelectric conversion/storage sections to a common charge detecting section, a potential detecting circuit for detecting charges transferred to the charge detecting section, generating a potential corresponding to an amount of detected charges and transmitting the potential to a corresponding one of vertical signal lines, a reset circuit for discharging the charges transferred to the charge detecting section, and an address circuit for selectively activating the potential detecting circuit, a vertical driving circuit provided in correspondence to each pixel row of the imaging area, for driving the first and second charge readout circuits, reset circuit and address circuit of each of the unit cells at preset timings, signal processing circuits respectively attached to the

vertical signal lines which are respectively provided  
for columns of the unit cells, for performing required  
signal processes; a horizontal driving circuit for  
scanning outputs of the signal processing circuits in a  
5 horizontal direction at preset timings to detect the  
same, and an output circuit for outputting output  
signals of the signal processing circuits detected by  
the scanning operation by the horizontal driving  
circuit, comprising the steps of driving the first and  
10 second charge readout circuits at substantially the  
same timing by use of the vertical driving circuit;  
transferring the charges stored in the first and second  
photoelectric conversion/storage sections to the charge  
detecting section and adding the charges together;  
15 detecting the added charges by use of the potential  
detecting circuit; generating a potential corresponding  
to an amount of the detected charges and transmitting  
the potential to the vertical signal line; and  
outputting the potential from the output circuit via  
20 the signal processing circuits.

According to the above method, since the charges  
read out from the first and second photoelectric  
conversion/storage sections in each of the unit cells  
are transferred to and added together in the common  
25 charge detecting section and the added charges are  
detected and read out by the potential detecting  
circuit, a sufficient amount of readout charges can be

attained and a lowering in the S/N ratio can be suppressed when the high-speed driving operation is effected.

Further, the object of this invention can be  
5 attained by a readout method of a solid-state imaging device which has first and second operation modes and includes an imaging area having unit cells arranged in a two-dimensional fashion on a semiconductor substrate, each of the unit cells including a photoelectric  
10 conversion/storage section for photoelectrically converting incident light and storing charges thus generated, a charge readout circuit for transferring charges stored in the photoelectric conversion/storage section to a charge detecting section, a potential  
15 detecting circuit for detecting charges transferred to the charge detecting section, generating a potential corresponding to an amount of detected charges and transmitting the potential to a corresponding one of vertical signal lines, a reset circuit for discharging  
20 the charges transferred to the charge detecting section, and an address circuit for selectively activating the potential detecting circuit, a vertical driving circuit provided in correspondence to each pixel row of the imaging area, for driving the charge readout circuit,  
25 reset circuit and address circuit of each of the unit cells at preset timings, signal processing circuits respectively attached to the vertical signal lines

which are respectively provided for columns of the unit cells, for performing required signal processes, horizontal readout switching circuits for controlling transfer of outputs of the signal processing circuits corresponding to the respective vertical signal lines to a horizontal signal line, a horizontal driving circuit for controlling the horizontal readout switching circuits at preset timing; and an output circuit for outputting output signals of the signal processing circuits which are read out to the horizontal signal line by controlling the horizontal readout switching circuits by use of the horizontal driving circuit, comprising a step of the first operation mode of causing the horizontal driving circuit to sequentially turn ON the horizontal readout switching circuits corresponding to the vertical signal lines; and sequentially outputting the output signals of the signal processing circuits corresponding to the vertical signal lines from the output circuit via the horizontal signal line; and a step of the second operation mode of causing the horizontal driving circuit to turn ON the horizontal readout switching circuits corresponding to a plurality of vertical signal lines at substantially the same time; reading out the output signals of the signal processing circuits corresponding to the plurality of vertical signal lines to the horizontal signal line and

averaging the output signals; and outputting the averaged output signals of the signal processing circuits from the output circuit.

According to the above method, since the signals  
5 derived from the respective vertical signal lines are sequentially read out in the first operation mode and the signals derived from plural columns of the vertical signals lines are averaged and read out in the second operation mode, a sufficient amount of readout charges  
10 can be attained in the second operation mode in which the high-speed driving operation is effected and the S/N ratio can be improved over a case wherein the number of readout photodiodes is reduced. Further, since the common horizontal readout switching circuits  
15 are used in the first and second operation modes, occurrence of fixed pattern noise can be sufficiently avoided in comparison with a case wherein different transistors are used depending on the modes when the horizontal readout switching circuits are constructed  
20 by transistors.

Further, with the above method, plural columns of vertical signal lines used for averaging the signals simply by changing the timings can be selected and the output signals of the signal processing circuits  
25 attached to the respective vertical signal lines can be directly read out to the horizontal signal line without using the capacitive coupling. Therefore, particularly,



when signals read out from the vertical signal lines which are not adjacent to each other are averaged, it is unnecessary to capacitively couple the plural columns to the horizontal signal line over a signal line. Thus, a problem of signal crosstalk which tends to occur when the plural columns are capacitively coupled over the signal line can be avoided and it is particularly preferable when signals are averaged by use of a color sensor using an RGB stripe filter.

10 Additional objects and advantages of the invention will be set forth in the description which follows, and in part will be obvious from the description, or may be learned by practice of the invention. The objects and advantages of the invention may be realized and  
15 obtained by means of the instrumentalities and combinations particularly pointed out hereinafter.

#### BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWING

The accompanying drawings, which are incorporated in and constitute a part of the specification,  
20 illustrate presently preferred embodiments of the invention, and together with the general description given above and the detailed description of the preferred embodiments given below, serve to explain the principles of the invention.

25 FIG. 1 is a circuit diagram for illustrating the conventional solid-state imaging device;

FIG. 2 is a timing chart showing conventional

pulse timings used for driving the solid-state imaging device shown in FIG. 1;

FIG. 3 is a timing chart showing the correlation between the conventional horizontal readout pulse and clear pulse in the solid-state imaging device shown in  
5 FIG. 1;

FIG. 4 is a timing chart showing pulse timings considered when driving the solid-state imaging device shown in FIG. 1 at high speed;

FIG. 5 is a timing chart showing other pulse timings considered when driving the solid-state imaging device shown in FIG. 1 at high speed;  
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FIG. 6 is a circuit diagram for illustrating a solid-state imaging device according to a first embodiment of this invention;  
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FIG. 7 is a timing chart for illustrating the readout operation of the solid-state imaging device according to the first embodiment of this invention;

FIG. 8 is a circuit diagram for illustrating a solid-state imaging device according to a second embodiment of this invention;  
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FIG. 9 is a timing chart for illustrating the readout operation of the solid-state imaging device according to the second embodiment of this invention;

FIG. 10 is a circuit diagram for illustrating a solid-state imaging device according to a third embodiment of this invention;  
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FIG. 11 is a timing chart for illustrating the readout operation of the solid-state imaging device according to the third embodiment of this invention; and

5           FIG. 12 is a timing chart for illustrating the readout operation of a solid-state imaging device according to a fourth embodiment of this invention.

#### DETAILED DESCRIPTION OF THE INVENTION

##### [First Embodiment]

10           FIG. 6 is a circuit diagram showing the construction of a solid-state imaging device according to one embodiment of this invention. Like the case of FIG. 1, in FIG. 6, a solid-state imaging device having two photodiodes arranged in each unit cell is taken as  
15           an example.

Unit cells are arranged in a two-dimensional fashion in an imaging area on a semiconductor substrate. More precisely, the unit cells are arranged in  $i$  rows and  $j$  columns, where  $i$  and  $j$  are integers. Of these  
20           unit cells, six representative ones are illustrated in FIG. 6. The six unit cells  $P$  are arranged in two adjacent rows  $m$  and  $m+1$  and three adjacent columns  $n-1$ ,  $n$  and  $n+1$ ; they are located at intersections  $(m, n-1)$ ,  $(m, n)$ ,  $(m, n+1)$ ,  $(m+1, n-1)$ ,  $(m+1, n)$  and  $(m+1, n+1)$ .

25           An address pulse line  $LAD_i$ , first and second readout pulse lines  $LR1_i$ ,  $LR2_i$  and reset pulse line  $LRS_i$  are arranged in the horizontal direction for each

pixel row of the unit cells  $P(i,j)$ . The unit cells  $P(i,j)$  are supplied with an address pulse  $\phi ADi$ , first and second readout pulses  $\phi R1i$ ,  $\phi R2i$ , and reset pulse  $\phi RSi$  from a pulse generating section 20 used as a vertical driving circuit via the address pulse line  $LADi$ , first and second readout pulse lines  $LR1i$ ,  $LR2i$  and reset pulse line  $LRSi$ . An output signal of a pixel row selection switching circuit 30 is supplied to the pulse generating section 20. The pixel row selection switching circuit 30 controls the pulse generating section 20 based on a signal  $LA$  for specifying a high-resolution mode and a signal  $HA$  for specifying a high-speed driving mode which are respectively supplied to input terminals 31 and 32. With this connection, readout pulses  $\phi R1i$ ,  $\phi R2i$  of different timings in the high-resolution mode and high-speed driving mode are output from the pulse generating section 20.

Further, vertical signals line  $Sj$  are respectively provided in the vertical direction for columns of the unit cells  $P(i,j)$ . Current sources  $Ij$  are respectively provided between one-side ends of the vertical signal lines  $Sj$  and the ground node. The other ends of the vertical signal lines  $Sj$  are respectively connected to one-side ends of the current paths of shift transistors (shift gates)  $SHj$ . The gates of the shift transistors  $SHj$  are commonly connected to a shift pulse line  $LSH$ .

One-side electrodes of coupling capacitors

(capacitances) CAj are respectively connected to the other ends of the current paths of the shift transistors SHj and the current paths of horizontal readout transistors (horizontal readout gates) Hj used as horizontal readout switching circuits are respectively connected between the other electrodes of the capacitors CAj and a horizontal signal line 24. The gates of the horizontal readout transistors Hj are respectively connected to horizontal readout pulse lines LHj. A capacitor which is equivalently represented by a capacitor 25 is associated with the horizontal signal line 24.

Charge storage capacitors (capacitances) CBj are respectively connected between the other electrodes of the capacitors CAj and the ground node. The current paths of clamping transistors (clamping gates) CLPj for offset elimination are respectively connected between connection nodes of the capacitors CAj and CBj and the positive terminal of a clamping DC power supply 23. The gates of the transistors CLPj are connected to a clamp line LCLP.

The shift transistor SHj, capacitors CAj, CBj and clamping transistor CLPj constitute a noise canceller circuit used as a signal processing circuit.

A pulse generating section 21 supplies a shift pulse  $\phi_{SH}$  to the gates of the shift transistors SHj via the shift pulse line LSH and supplies a clamp pulse

$\phi$ CLP to the gates of the clamping transistors CLPj via the clamp pulse line LCLP to control the operations thereof.

Further, a pulse generating section 22 used as a  
5 horizontal driving circuit supplies horizontal readout pulses  $\phi$ Hj to the gates of the respective horizontal readout transistors Hj via the horizontal readout pulse lines LHj and supplies a clear pulse  $\phi$ CR to the gate of a potential resetting transistor (potential  
10 resetting gate) 28 via a clear pulse line LCR. The potential resetting transistor 28 is used for resetting the potential of a capacitor (capacitance) 25, and one end of the current path thereof is connected to the positive terminal of a DC power supply 29 for  
15 generating a potential at the reset time and the other end of the current path thereof is connected to the horizontal signal line 24. The voltage value (which is indicated by Vb) of the DC power supply 29 is determined by taking the characteristic of an output  
20 buffer circuit 26 into consideration and the clear pulse  $\phi$ CR is supplied to the gate of the transistor 28 to set the potential of the capacitor 25 to the potential Vb before the horizontal readout pulses  $\phi$ Hj are supplied.

25 The horizontal signal line 24 is connected to the input terminal of the output buffer circuit 26 used as an output circuit for detecting the potential of the

horizontal signal line 24, subjecting the potential to impedance conversion and outputting the potential to the exterior. The output end of the output buffer circuit 26 is connected to an output terminal 27.

5           Next, the internal construction of the unit cell  $P(i,j)$  is explained. In FIG. 6, the unit cell  $P(m, n-1)$  is taken as an example and shown in detail, but the other unit cells are also constructed in the same manner. Each unit cell  $P(i,j)$  includes  
10   photodiodes 1-1, 1-2 as photoelectric conversion/storage sections, readout transistors (readout gates) 2-1, 2-2 as charge readout circuits, reset transistor (reset gate) 4 as a reset circuit, potential detecting transistor (potential detecting gate) 5 as a potential  
15   detecting circuit, address transistor (address gate) 6 as an address circuit and the like.

          The anodes of the photodiodes 1-1, 1-2 are grounded and the cathodes thereof are respectively connected to one-side ends of the current paths of the  
20   readout transistors 2-1, 2-2. The other ends of the readout transistors 2-1, 2-2 are connected to a storage node 3 (common charge detecting section) in which charges read out from the photodiodes 1-1, 1-2 are temporarily stored and the gates thereof are  
25   respectively connected to the readout pulse lines  $LR1i$ ,  $LR2i$ . A reset transistor 4 is connected between the storage node 3 and a power supply 7 and the gate of the

reset transistor 4 is connected to a corresponding one of the reset pulse lines  $LRS_i$ . One end of the current path of the potential detecting transistor 5 is connected to a corresponding one of the vertical signal lines  $S_j$  via the output line 8 of the corresponding unit cell  $P(i,j)$  and the gate thereof is connected to the storage node 3. The potential detecting transistor 5 is used for detecting the charges transferred to the storage node 3 and transmits a potential corresponding to an amount of detected charges to the corresponding vertical signal line  $S_j$  via the output line 8. The current path of the address transistor 6 is connected between the other end of the current path of the potential detecting transistor 5 and the power supply 7 and the gate thereof is connected to a corresponding one of the address pulse lines  $LAD_i$ . The address transistor 6 is used for activating the potential readout operation of the corresponding unit cell  $P(i,j)$ . In FIG. 6, in order to clarify the drawing, power supply lines are omitted.

In the first embodiment, the timings of pulse signals supplied to the respective unit cells  $P(i,j)$  from the pulse generating section 20 are changed by supplying a signal LA for specifying the high-resolution mode or a signal HA for specifying the high-speed driving mode to the input terminal 31 or 32 so as to cause the pixel row selection switching



section 30 to control the pulse generating section 20 and thus the high-resolution mode and high-speed driving mode are selectively switched.

5 If the signal LA is supplied to the input terminal 31, the high-resolution mode is set, the same operation as in the conventional case described with reference to the timing charts of FIGS. 2 and 3 is performed, and charges are individually read out from the photodiodes 1-1, 1-2 provided in each unit cell  $P(i,j)$ .

10 If the signal HA is supplied to the input terminal 32, the high-speed driving mode is set, second readout pulses  $\phi R2m$ ,  $\phi R2m+1$  are set to the high level at the same timing as first readout pulses  $\phi R1m$ ,  $\phi R1m+1$  as shown in the timing chart of FIG. 7 so as to  
15 simultaneously drive the readout transistors 2-1 and 2-2. As a result, light incident on the photodiodes 2-1, 2-2 is photoelectrically converted and charges thus produced are added together in the storage node 3 and read out.

20 Next, the readout operation in the high-speed driving mode in the m-th row of the unit cells is explained by taking the unit cell  $P(m, n-1)$  as an example.

Charges produced by photoelectrically converting  
25 light incident on the photodiodes 1-1, 1-2 are stored in the photodiodes 1-1, 1-2 until the readout transistors 2-1, 2-2 are turned ON. The operation

which is first effected in the horizontal scanning  
retrace interval is to set the address pulse  $\phi_{ADM}$  to  
the high level so as to turn ON the address transistor  
6 ( $t=t_0$ ) and construct a source-follower circuit by use  
5 of the vertical signal line  $S_{n-1}$ , current source  $I_{n-1}$   
and potential detecting transistor 5 so that the charge  
of the storage node 3 can be detected by use of the  
potential detecting transistor 5. As a result, only a  
potential determined by the gate potential of the  
10 potential detecting transistor 5 and corresponding to  
the charge amount of the storage node 3 is transmitted  
to the vertical signal line  $S_{n-1}$ .

Further, a dark current integrated value stored in  
the storage node 3 can be discharged by setting the  
15 reset pulse  $\phi_{RSm}$  to the high level to turn ON the  
reset transistor 4 at the beginning of the horizontal  
scanning retrace interval. Thus, the storage node 3  
can be set at the power supply voltage value ( $V_{dd}$ ).

At this time, a shift pulse  $\phi_{SH}$  is output from  
20 the pulse generating section 21 and supplied to the  
gates of the shift transistors  $SH_j$  to turn ON the shift  
transistors  $SH_j$ .

Next, at the time  $t=t_1$ , a clamp pulse  $\phi_{CLP}$  is  
supplied from the pulse generating section 21 to the  
25 gates of the clamping transistors  $CLP_j$  to turn ON the  
clamping transistors  $CLP_j$  and perform the offset  
elimination process.

At the time  $t=t_2$ , the readout pulses  $\phi R_{1m}$ ,  $\phi R_{2m}$  are set to the high level to substantially simultaneously turn ON the readout transistors 2-1 and 2-2 so that charges stored in the photodiodes 1-1, 1-2 can be transferred to and added together in the storage node 3. The amount of charges stored in the storage node 3 is detected by the potential detecting transistor 5 and a potential corresponding to the detected charge amount is generated and transmitted to the vertical signal line  $S_{n-1}$ .

The operation after this is the same as in the conventional high-resolution mode.

Next, at the time  $t=t_3$ ,  $t_4$ ,  $t_5$ , the readout operation for the next row (( $m+1$ )th row) of the unit cells adjacent to the above row is effected in the same manner as described above.

That is, in the first embodiment, signal charges are simultaneously read out from the two photodiodes 1-1, 1-2 in each unit cell  $P(i,j)$  and supplied to the storage node 3 in the high-speed driving mode. As a result, the readout time for one frame is reduced by half in the same manner as in the case of FIG. 4, but in this case, the sum of the signal charges derived from the photodiodes 1-1, 1-2 is treated as one signal. Therefore, a lowering in the S/N ratio can be suppressed in comparison with the conventional technique in which the signal charge derived from one

of the photodiodes is discharged via the reset transistor 4 and a lowering in the sensitivity can be suppressed since the signal charge amount is increased.

[Second Embodiment]

5           FIG. 8 is a circuit diagram for illustrating a solid-state imaging device according to a second embodiment of this invention. The circuit is similar to that of FIG. 6 except that a pixel column selection circuit 40 and pixel column selection information  
10           processing circuit (decoder) 41 are provided instead of the pixel row selection switching circuit 30 and input terminals 31, 32 in the circuit of FIG. 6. A signal SCA for selecting a pixel column is supplied to and decoded by the pixel column selection information  
15           processing circuit 41 and the decoded signal SCA is supplied to the pixel column selection circuit 40. The pixel column selection circuit 40 controls the pulse generating section 22 and causes the pulse generating section 22 to output a horizontal readout pulse at  
20           different timings according to the high-resolution mode and high-speed driving mode.

          Since the other basic construction is the same as that of the circuit of FIG. 6, like portions are denoted by the same reference numerals and the  
25           explanation therefor is omitted.

          FIG. 9 is a timing chart for illustrating the solid-state imaging device shown in FIG. 8. Like the

first embodiment, in the second embodiment, the high-resolution mode and high-speed driving mode are selectively switched. However, in the second embodiment, a horizontal readout pulse  $\phi H_j$  supplied to the gate of a horizontal readout transistor  $H_j$  and a horizontal readout pulse  $\phi H_{j+1}$  supplied to the gate of an adjacent horizontal readout transistor  $H_{j+1}$  are simultaneously set to the high level to simultaneously turn ON the two adjacent horizontal readout transistors  $H_j$ ,  $H_{j+1}$  by controlling the pulse generating section 22 by use of the pixel column selection circuit 40 and pixel column selection information processing circuit 41. For example, by simultaneously setting the horizontal readout pulses  $\phi H_1$  and  $\phi H_2$ ,  $\phi H_3$  and  $\phi H_4$ ,  $\phi H_5$  and  $\phi H_6$ , ... to the high level, signals are simultaneously read out from the adjacent columns of the unit cells, supplied to and averaged in the horizontal signal line 24 and then the averaged value is output from the output terminal 27 via the output buffer circuit 26.

In order to simplify the explanation, it is assumed that there is no variation in the capacitances of the capacitors  $CA_j$ ,  $CB_j$  and the capacitance  $C_{ij}$ , they are respectively denoted by  $CA$ ,  $CB$ ,  $C$ , charges read out to the storages node 3 are denoted by  $Q_j$ ,  $Q_{j+1}$ , and charges stored in the capacitors  $CB$  are denoted by  $Q2_j$ ,  $Q2_{j+1}$ . Then, the following equations are obtained.

$$Q_{2j} = CBV_{ref} + mQ_j / C \cdot CACB / (CA + CB) \quad \dots (10)$$

$$Q_{2j+1} = CBV_{ref} + mQ_{j+1} / C \cdot CACB / (CA + CB) \quad \dots (11)$$

Therefore, if the horizontal readout transistors  $H_j$ ,  $H_{j+1}$  are simultaneously turned ON, the potential of the horizontal signal line 24 can be set as expressed by the following equation (12).

$$\begin{aligned} & (Q_1 + Q_{2j} + Q_{2j+1}) / (CH + 2CB) \\ & = (CH \cdot V_b + 2CBV_{ref}) / (CH + 2CB) + m(Q_j + Q_{j+1}) / \\ & \quad C \cdot CACB / (CA + CB) \cdot (CH + 2CB) \quad \dots (12) \end{aligned}$$

As is understood from the equation (12), an output signal derived by averaging signal charges read out from the two selected photodiodes is obtained in the horizontal signal line 24. As a result, like the first embodiment, the readout time for one frame can be reduced by half.

In addition, since the average of the signal charges obtained from the two photodiodes provided in each of the adjacent unit cells is treated as one signal so that the signal charge amount can be increased in comparison with a case where the number of readout photodiodes is reduced, the S/N ratio can be improved.

#### [Third Embodiment]

FIG. 10 is a circuit diagram for illustrating a solid-state imaging device according to a third embodiment of this invention. The circuit is basically similar to that of FIG. 8 except that the control

operation for controlling the pulse generating section 22 by use of a pixel column selection circuit 40' and pixel column selection information processing circuit (decoder) 41' is different, and as shown in the timing chart of FIG. 11, horizontal readout transistors arranged for every three unit cells are turned ON at the same timing. That is, signal charges are simultaneously read out from every third columns of unit cells by simultaneously setting the horizontal readout pulses  $\phi H1$  and  $\phi H4$ ,  $\phi H2$  and  $\phi H5$ ,  $\phi H3$  and  $\phi H6$ , ... to the high level and the average value thereof is output.

Therefore, the average value is output at the pulse repetition rate of the horizontal readout pulse. The readout method described in the third embodiment is preferable for a construction (RGB stripe filter) in which color filters corresponding to RGB are arranged in a stripe form. The other basic construction, operation and effect are the same as those described with reference to FIG. 8.

A solid-state imaging device for averaging signals read out from a plurality of vertical signal lines and outputting the averaged value is known in the art. As this type of solid-state imaging device, an example for effecting the operation (high-resolution mode) for independently and sequentially scanning outputs of individual photodiodes arranged on the same row in the

horizontal direction and outputting the same and  
effecting the operation (high-speed driving mode) for  
sequentially scanning the average of outputs of two  
adjacent photodiodes in the horizontal direction and  
5 outputting the same is already disclosed in Jpn. Pat.  
Appln. KOKAI Publication No. 10-4520.

In FIGS. 2 and 3 in the above Jpn. Pat. Appln.  
KOKAI Publication, the technique for obtaining an image  
in two operation modes by capacitively coupling readout  
10 signals with output terminals  $VO2_{k-1}$ ,  $VO2_k$  provided for  
the high-resolution mode via switching transistors  $252_1$ ,  
 $252_2$  after they are subjected to impedance conversion,  
clamping process and sample-hold process for each line  
and then passed through buffer amplifiers  $251_1$ ,  $251_2$ ,  
15 capacitively coupling the readout signal with an output  
terminal  $VO_k$  provided for the high-speed driving mode  
via switching transistors  $253_1$ ,  $253_2$  and sequentially  
scanning them as required is disclosed.

The above technique is similar to the present  
20 invention in that the average of outputs of a plurality  
of vertical signal lines is output, but this embodiment  
has the following advantages over the above Jpn. Pat.  
Appln. KOKAI Publication owing to a difference between  
the methods for realizing the techniques.

25 (1) The common switches (readout transistors  $H_j$ )  
used at the outputting time for each column are used at  
the average outputting time and generation of fixed



pattern noise caused by using different switching transistors can be prevented.

(2) The columns subjected to the averaging process can be selected simply by changing the timings for driving the readout transistors H<sub>j</sub> and it is unnecessary to output the signal to the horizontal signal line 24 by capacitive coupling at the average outputting time as in the technique described in the above Jpn. Pat. Appln. KOKAI Publication.

(3) Particularly, when the average of outputs from the vertical signal lines which are not adjacent to each other is taken, it is necessary to make capacitive coupling over the signal line in the technique described in the above Jpn. Pat. Appln. KOKAI Publication and a problem of signal crosstalk occurs. This develops into a serious problem particularly in a case where the average is taken by use of a color sensor using RGB stripe filters, but such a problem does not occur in the third embodiment.

[Fourth Embodiment]

One of the basic ideas of this invention is that a potential signal corresponding to the average value of outputs from vertical signal lines corresponding to the selected horizontal readout transistors can be obtained on the horizontal signal line when preset timing is set to turn ON some of the horizontal readout transistors at the same time.

Before explaining the fourth embodiment, the above idea is described in detail. Assume now that the capacitance of an i-th storage node (3 in FIG. 6) corresponding to a j-th vertical signal line S<sub>j</sub> is set to C<sub>ij</sub> as in the equation (1). An amount of charges transferred from a pixel to the storage node 3 is set to Q<sub>ij</sub> since there is a possibility that the charge amount may be different for each node. At this time, the potential V<sub>ij</sub> of the vertical signal line S<sub>j</sub> is expressed by the following equation (13).

$$V_{ij} = mQ_{ij}/C_{ij} + mV_{dd} + V_{0ij} \quad \dots (13)$$

where m indicates the modulation degree of the transistor, and V<sub>0ij</sub> indicates a threshold voltage of the transistor 5 and expresses an offset voltage determined by a variation in the current source I<sub>j</sub>. By using the above symbols, the charge amount Q<sub>2j</sub> corresponding to the equation (8), that is, the amount of charges stored in the capacitor C<sub>Bj</sub> is expressed as follows.

$$Q_{2j} = C_{Bj}V_{ref} + mQ_{ij}/C_{ij} \cdot C_{Aj}C_{Bj}/(C_{Aj} + C_{Bj}) \quad \dots (14)$$

At this time, if some of the horizontal readout transistors H<sub>j</sub> are simultaneously turned ON, the potential V of the horizontal signal line 24 is expressed by the following equation (15) in correspondence to the equation (9) while it is assumed that  $\Sigma$  expresses the sum of charges associated with the readout transistors which are simultaneously turned ON.

$$\begin{aligned} V &= (CH \cdot V_b + \sum Q_{2j}) / (CH + \sum CB_j) \\ &= (CH \cdot V_b + \sum V_{ref} CB_j) / (CH + \sum CB_j) + \sum m Q_{ij} / C_{ij} \cdot CA_j CB_j / \\ &\quad (CA_j + CB_j) \cdot (CH + \sum CB_j) \quad \dots (15) \end{aligned}$$

As already explained, the ratio of capacitances results in the ratio of the geometrical sizes and is a relatively easily controllable amount. If the number of readout transistors which are simultaneously turned ON is N and the subscript j is omitted from the capacitors CA<sub>j</sub>, CB<sub>j</sub> with the above fact taken into consideration, the potential V can be expressed as follows.

$$\begin{aligned} V &= (CH \cdot V_b + NV_{ref} CB) / (CH + NCB) \\ &\quad + [CACB / (CA + CB) \cdot (CH/N + CB)] \cdot [(1/N)m \sum Q_{ij} / C_{ij}] \quad \dots (16) \end{aligned}$$

That is, it is obtained as a signal derived by adding an average signal output  $(1/N)m \sum Q_{ij} / C_{ij}$  times a constant number to a preset amount  $(CH \cdot V_b + NV_{ref} CB) / (CH + NCB)$ . Thus, the average value for a desired number of vertical signal lines can be detected. When all of the horizontal readout transistors are simultaneously turned ON, it is supposed that N is sufficiently larger than 1 and the equation (16) can be rewritten as follows.

$$V = V_{ref} + CA / (CA + CB) (1/N)m \sum Q_{ij} / C_{ij} \quad \dots (17)$$

This corresponds to an equation attained by setting CH=0 and replacing  $mQ/C_{ij}$  by the average value  $(1/N)m \sum Q_{ij} / C_{ij}$  for one row in the equation (9).

Next, the fourth embodiment of this invention is explained with reference to the solid-state imaging device of FIG. 6 and the timing chart of FIG. 12. The fourth embodiment is suitable for AGC for controlling the shutter speed and diaphragm opening to attain adequate exposure of a video camera, electronic still camera or the like by using the average value of readout signal charges as described above.

Generally, in a solid-state imaging device capable of effecting the electronic shutter operation, a pulse generating section for an electronic shutter is provided in addition to the readout pulse generating sections 20, 21, 22 as shown in FIG. 6. Like the pulse generating section 20 used as the vertical driving circuit, the pulse generating section for the electronic shutter outputs various pulse signals to scan unit cell rows to be selected at preset timings. The pulse generating section for the electronic shutter and the pulse generating section used as the vertical driving circuit are constructed by use of shift registers, for example. Specific to-be-selected rows are selected and controlled at two timings in one field period by the pulse generating section for the electronic shutter and the pulse generating section used as the vertical driving circuit.

The electronic shutter operation for controlling the light receiving time can be equivalently attained

by causing the pulse generating section for the electronic shutter to selectively control the to-be-selected row and start storage of a pixel signal before the pulse generating section used as the vertical driving circuit selectively controls the to-be-selected row and reads out a pixel signal to the vertical signal line.

However, since the electronic shutter operation is a known technique and this embodiment is not directly related to the electronic shutter operation, the detail explanation for the basic construction and the operation is omitted here.

The timing chart shown in FIG. 12 illustrates a determination method of illuminance on the sensor surface for determining proper storage time (shutter speed) or diaphragm opening and is set to detect the average output of a preset representative row (for example, one row at the center of the sensor surface) before driving the sensor. In FIG. 12, the timings of various pulse signals are shown with attention paid only to a to-be-selected row.

That is, first, at the time  $t=t_0$ , the address pulse  $\phi_{AD}$ , readout pulses  $\phi_{R1}$ ,  $\phi_{R2}$  and reset pulse  $\phi_{RS}$  generated from the pulse generating section 20 are set to the high level, and at the same time, the shift pulse  $\phi_{SH}$  generated from the pulse generating section 2 and the clear pulse  $\phi_{CR}$  generated from the pulse

generating section 22 are set to the high level. As a result, the storage node 3 is connected to the Vdd power supply 7 via the reset transistor 4, and therefore, the potential is detected by the potential detecting transistor 5 and the potential of the vertical signal line (for example,  $S_n$ ) is set to a high potential corresponding to the power supply voltage Vdd. Further, since all of the horizontal readout pulses  $\phi_H$  are set at the low level, all of the horizontal readout transistors H are set in the OFF state and since the potential resetting transistor 28 is turned ON according to the high level of the clear pulse  $\phi_{CR}$ , the potential of the horizontal signal line 24 is set to a potential determined by the voltage of the DC power supply 29. Therefore, the potential of the output terminal 27 is set to a potential corresponding to the potential of the horizontal signal line 24.

Next, while the address pulse  $\phi_{AD}$ , shift pulse  $\phi_{SH}$  and clear pulse  $\phi_{CR}$  are kept at the high level, the reset pulse  $\phi_{RS}$  is set to the low level to terminate the reset operation ( $t=t_1$ ). At this time, the reset transistor 4 is turned OFF, the storage node 3 is separated from the power supply 7 and the potential of the vertical signal line  $S_n$  is lowered by capacitive coupling.

Next, at the time  $t=t_2$ , the clamping transistor  $CLP_n$  is turned ON by supplying the clamp pulse  $\phi_{CLP}$  to

the gate thereof and an offset caused by variations in the current source  $I_n$  and the threshold voltage of the potential detecting transistor 5 is eliminated ( $t=t_2$ ) by supplying a preset voltage to the electrode of one  
5 of the capacitors  $C_{An}$ ,  $C_{Bn}$  from the DC power supply 23.

After this, when the readout pulse  $\phi_{R1}$  for the selected row is set to the high level again, the readout transistor 2-1 is turned ON to further lower the potential of the vertical signal line  $S_n$  according  
10 to the amount of charges stored in the photodiode 1-1 ( $t=t_3$ ).

At the time  $t=t_4$ , if the shift pulse  $\phi_{SH}$  and clear pulse  $\phi_{CR}$  are set to the low level, all of the shift transistors SH and potential resetting transistor  
15 28 are turned OFF and the unit cells  $P(i,j)$  and DC power supply 29 are separated from the horizontal signal line 24.

After this, when all of the horizontal readout pulses  $\phi_H$  are set to the high level, all of the  
20 horizontal readout transistors H are turned ON, charges stored in the capacitors CA, CB are transferred to the horizontal signal line 24 and the potential of the horizontal signal line 24 is varied by  $\Delta A$  according to the average value of charges stored in the capacitors  
25 CA, CB ( $t=t_5$ ).

Then, at the time  $t=t_6$ , when the address pulse  $\phi_{AD}$  for the selected row is set to the low level, the

address transistor 6 is turned OFF to terminate the readout operation.

5 In the readout operation described above, the storage time of charges into the storage node 3 is set by the interval of the readout pulse  $\phi R1$  for the selected row and the potential  $\Delta A$  of the average value (signal corresponding to the equations (16) and (17)) of sensor outputs corresponding to the storage time for one line of the selected row is output. The average  
10 illuminance of the sensor surface is acquired according to the potential  $\Delta A$  and storage time setting information.

After this, the diaphragm opening or storage time is set according to the thus obtained average  
15 illuminance and then the normal operation is effected.

Thus, the average illuminance of the sensor surface can be acquired by effecting the simple driving operation without performing the readout operation for all of the pixels. Further, an external memory is not  
20 necessary.

It is possible to combine the fourth embodiment with the first embodiment so as to use the sum of the charges read out from the two photodiodes of one unit cell as an output signal. In this case, the readout  
25 pulses  $\phi R1$ ,  $\phi R2$  input to each unit cell as readout pulses for the selected row can be driven substantially at the same timing.



In the above embodiments, a case wherein two photodiodes are provided in each unit cell is explained, but the number of photodiodes is not limited to two. For example, in the solid-state imaging device of the  
5 second to fourth embodiments, one photodiode may be provided.

As described above, according to this invention, a solid-state imaging device capable of suppressing a lowering in the S/N ratio when the high-speed driving  
10 operation is effected can be attained.

Additional advantages and modifications will readily occur to those skilled in the art. Therefore, the invention in its broader aspects is not limited to the specific details and representative embodiments  
15 shown and described herein. Accordingly, various modifications may be made without departing from the spirit or scope of the general inventive concept as defined by the appended claims and their equivalents.